

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

August 24, 2024

IGI Report Number

DESCRIPTION

SHAPE AND CUTTING STYLE

MEASUREMENTS

LG649492587

LABORATORY GROWN DIAMOND

EMERALD CUT

7.50 X 5.15 X 3.54 MM

GRADING RESULTS

CARAT WEIGHT

COLOR GRADE

CLARITY GRADE

1.35 CARAT

F

SI 1

ADDITIONAL GRADING INFORMATION

POLISH

SYMMETRY

FLUORESCENCE


EXCELLENT

EXCELLENT

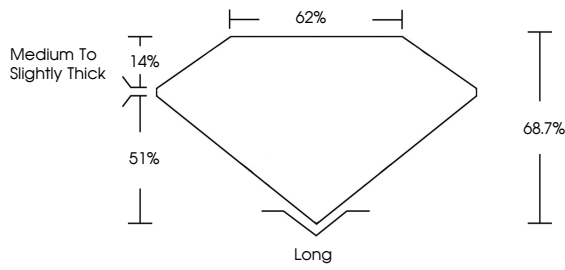
NONE

INSCRIPTION(S)

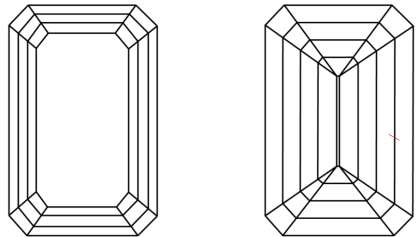
COMMENTS: THIS LABORATORY GROWN DIAMOND WAS CREATED BY CHEMICAL VAPOR DEPOSITION (CVD) GROWTH PROCESS. TYPE IIa

 LG649492587

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

IF

VS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Internally Flawless


Very Very Slightly Included

Very Slightly Included


Slightly Included

Included

Sample Image Used



LABORATORY GROWN DIAMOND REPORT



August 24, 2024

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG649492587

LABORATORY GROWN DIAMOND

EMERALD CUT

7.50 X 5.15 X 3.54 MM

GRADING RESULTS

CARAT WEIGHT

COLOR GRADE

CLARITY GRADE

1.35 CARAT

F

SI 1

ADDITIONAL GRADING INFORMATION

POLISH

SYMMETRY

FLUORESCENCE


EXCELLENT


EXCELLENT

NONE



INSCRIPTION(S)

COMMENTS: THIS LABORATORY GROWN DIAMOND WAS CREATED BY CHEMICAL VAPOR DEPOSITION (CVD) GROWTH PROCESS. TYPE IIa

 LG649492587



IGI



© IGI 2020, International Gemological Institute

FD - 10 20

August 24, 2024

IGI Report No LG649492587

EMERALD CUT

7.50 X 5.15 X 3.54 MM

Carat Weight

Color Grade

Clarity Grade

Depth

Table

Graile

Medium to Slightly Thick

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

1.35 CARAT

F

SI 1

68.7%


62%

Long

EXCELLENT

EXCELLENT

NONE

 LG649492587

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa